# **Grain-boundary segregation in aluminium-doped silicon carbide**

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Scanning transmission electron microscopy (STEM) was used to examine sintered and hot-pressed aluminium-doped silicon carbide. Grain-boundary segregation of AI was observed in both materials. Semi-quantitative analysis was carried out on the AI-saturated hot-pressed material. An estimated heat of segregation between 116 and 174 kJ mol<sup>-1</sup> was calculated from the STEM data and equilibrium segregation theory. Strain energy as a driving force was considered negligible. The data are consistent with a segregation model in which the driving force for segregation is the difference in the nature of bonding between the solute and solvent atoms. Fast grain-boundary diffusion of AI was suggested from a loss of AI during heat treatments.

## **1. Introduction**

Silicon carbide is a promising material for a variety of high-temperature structural applications. It has been shown that either  $\beta$ - or  $\alpha$ -SiC can be densified to near theoretical density with the addition of boron  $[1-3]$  or aluminium  $[4]$  together with excess carbon. Grain boundary and surface segregation phenomena may play important roles in determining effects of these dopants on densification and on high-temperature properties. Coblenz [5] has observed surface segregation of B in B-doped  $\beta$ -SiC by Auger electron spectroscopy (AES) and supported an earlier postulate that the effect of B is to inhibit coarsening by surface diffusion [6, 7].

There have been few reports on segregation in covalent materials, in contrast with the number of reports in metal and ionic systems. It may be expected that, due to directional covalent bonding, the segregation mechanism is different in the SiC system from other systems. The present study reports examination of Al-doped SiC by scanning transmission electron microscopy (STEM).

## **2. Experimental procedure**

#### 2.1. Sample preparation

Two kinds of materials were used in this study:

sintered and hot-pressed  $\alpha$ -SiC. The sintered sample was supplied by Dr H. Hausner, Technische Universität Berlin, West Germany, and details of the sintering procedures have been published [4]. The starting composition was 96.9 wt% SiC, 1.1 wt% At and 2 wt% C, and the starting materials were sintered at  $2100^{\circ}$  C for 20 min under an Ar atmosphere. The hot-pressed  $\alpha$ -SiC was manufactured by Electroschmertzwerk Kempten, West Germany was made from fine  $\alpha$ -SiC particles, hotpressed at  $2100^{\circ}$  C in graphite under pressure of about 40 MPa with the addition of 1.5 wt% A1.

Samples were sliced-off the bulk to a thickness of about 1 mm (thinner in some cases) with a thin diamond cutting wheel. They were given various heat treatments in a carbon tube resistance furnace. At the end of each heat treatment the furnace power was turned off; the initial cooling rate was approximately  $100^\circ$  C min<sup>-1</sup>.

Heat-treated and as-received samples were mechanically thinned by grinding with  $6 \mu m$ diamond paste (sometimes they were sliced to a half thickness with a diamond wheel before grinding) to a thickness of 40 to 80  $\mu$ m. Care was taken to ensure that the ground specimens represented bulk regions; i.e., taken from regions away from the surfaces. They were then further

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thinned by an ion micromilling instrument\* with argon ions accelerated through a potential of 6 to 10 kV until perforation was observed. A tilt angle of 20 to 30° was used. The thinning rate depended on such factors as accelerating voltage, ion current and angle of incidence, and in most cases it was in the range 3 to 5  $\mu$ m h<sup>-1</sup> gun<sup>-1</sup>.

# 2.2. STEM analysis

The samples were observed and X-ray microanalysis was carried out in a scanning transmisson electron microscope<sup>†</sup> (STEM). This instrument, equipped with a detector<sup> $\ddagger$ </sup> for energy dispersive X-ray analysis (EDAX), is sometimes referred to as a "dedicated" STEM or analytical electron microscope (AEM), and its design and modes of operation have been described in [8].

For analysis, the specimens were held in a graphite-nosed cartridge which allowed translation and tilting and which did not contribute spurious X-rays to the signal. The probe diameter and current were approximately 2.5 nm and approximately  $10^{-8}$  A at an accelerating voltage of 100 kV. The analysis was performed by orienting the grain boundaries parallel to the electron beam and then manually stepping the probe along a line perpendicular to the boundary. A count time varied from spot to spot such that a sum of A1 and Si X-ray counts exceeds 10 000 counts. During the analysis, the boundary was examined to ensure that no specimen drift occurred; when such a drift occurred it was kept to a minimum (less than 2.0 nm) by moving the boundary back to the original position.

For most of the analyses, a standard X-ray detector was used, which is limited to the detection of elements of atomic number,  $Z \ge 9$ . An ultra-thin-window X-ray detector<sup>§</sup>, which is capable of detecting lighter elements down to carbon, has very recently become available, and it was used for a few analyses.

After collection, a computer-generated semiempirical background was subtracted from the spectrum. A1 and Si peak intensities were then determined by fitting the energy locations and peak shapes of observed X-ray lines to Gaussian curves to minimize the error due to the overlap of two peaks.

# **3. Results**

## 3.1. Sintered SiC

STEM observations on the sintered samples revealed several features which are described below. In rare cases second phases were observed at three and four grain junctions. X-ray spectra taken at these second phases show that Fe is the major impurity present along with small amounts of other transition metals. These impurities were probably picked up during the milling process. Occasionally thin films were observed in porous regions. They were determined to be graphite from selected-area diffraction (SAD) patterns. An example of them, bright-field and annular darkfield images, is shown in Fig. 1. Since 2wt% of excess carbon was added prior to sintering, it is not surprising to find residual graphite. Major defects observed were stacking faults.

The only elements detected by EDAX in the bulk and at grain boundaries were Si and A1. X-ray intensities in bulk (and sometimes at grain boundaries) were low, near or below the detection limit. X-ray microanalysis across a grain boundary of as-sintered samples showed an enhancement of A1 concentration at the grain boundary. Since there was no indication of grain-boundary phase when observed at a magnification of 500 000 times, this enhancement is believed to be a solute segregation at grain boundary. It was found, however, that after several as-sintered specimens were examined, some did not show any segregation of A1 at grain boundaries while others did. This was due to inhomogeneous distribution of AI in the sample: less A1 in the outer regions than in the central regions. It was indeed found that when the STEM specimen was prepared from the outer region of the disc, no A1 segregation was observed; i.e. A1 X-ray signals both at grain boundaries and in the bulk were below the detection limit. Due to these inhomogeneities, only qualitative analyses were carried out on this material.

Thin sliced specimens (of thickness about  $150 \mu m$ ) were annealed at lower temperatures,  $1350^\circ$  C and  $1500^\circ$  C, for 1 to 10 h to examine the effect of temperature on the segregation. A1 segregation was observed in all samples although amounts of segregation varied from specimen to specimen, and no distinct correlation between the

<sup>\*</sup>IMMI, Commonwealth Scientific Corp., Alexandria, Virginia, USA.

tVG HB5, Vacuum Generators Microscopes Ltd, East Grinstead, UK.

<sup>&</sup>lt;sup>‡</sup> Kevex Corp., Foster City, California, USA.

<sup>§</sup> UTW6, Kevex Corp., Foster City, California, USA.



*Figure 1* STEM micrographs of sintered SiC: (a) bright-field and (b) annular dark-field. Thin films in porous regions are residual graphite.

annealing temperature and the amount of segregation was observed for the reason described above. The largest segregation was observed for the specimen annealed at  $1500^{\circ}$  C for 3 h and its segregation profile is shown in Fig. 2, in which are also shown profiles of the as-sintered specimen and of the specimen annealed at  $1500^{\circ}$ C for 3h and subsequently at  $2100^{\circ}$  C for 3 h. The last specimen was a part of the slice which showed the largest segregation, and it did not show any segregation after the second heat treatment. If equilibrium segregation had taken place, there should have been segregation of AI since the second annealing temperature was the same as the sintering temperature. These results are explained by out-diffusion of A1, as was observed during sintering [4].

The results on the sintered material clearly show that the A1 segregation onto grain boundaries does take place, and they suggest that the segregation is enhanced by annealing at lower temperatures.

#### **3.2. Hot-pressed** SiC

The most characteristic feature of the hot-pressed material compared with the sintered material is the existence of Al-rich second phases which were found by STEM observations. Since hot-pressing would almost prevent A1 out-diffusion, it is reasonable that the hot-pressed material should contain Al-rich second phases considering the solubility limit (about 0.7 wt% at  $2100^{\circ}$ C)[9] and the amount of A1 added (1.5 wt%). Examples of second phases shown in Figs 3 and 4, in which X-ray spectra taken at each second phase are also shown. The X-ray spectrum in Fig. 4 was taken by the ultrathin-window (UTW) detector and it shows that the second phase is an oxide. Some other second



*Figure 2* Results of X-ray microanalysis across grain boundary in sintered SiC.



*Figure 3* (a) STEM micrograph (bright-field image) and (b) X-ray spectrum taken at the second phase in hot-pressed SiC.

phases contain such impurities as Ti, Fe, and other transition metals. Grain boundaries were observed to be clean; i.e., there was no indication of grain boundary phase, as shown in Fig. 5. Elements detected at grain boundaries and in bulk were A1 and Si (and C when the UTW detector was used). X-ray microanalysis with an as-hot-pressed sample showed an enhancement of A1 concentration at a grain boundary. This material, therefore, seems to have the advantage of carrying out quantitative analyses on grain-boundary segregation, since the local equilibrium of the A1 concentration near the grain boundaries may be assumed as long as the A1 saturation is maintained in the sample.

Segregation profiles of samples heat-treated at  $1800^{\circ}$  C, 2000° C, and 2200° C are shown in Fig. 6. In each sample, the existence of Al-rich second phases were observed. It is clearly seen from Fig. 6 that a lower annealing temperature resulted in a larger amount of segregation, consistent with the theory of equilibrium segregation. X-ray microanalyses were carried out on three more specimens

which were heat-treated (a) at  $1800^{\circ}$  C for 10h, (b) at  $1800^\circ$  C for 10 h and subsequently at  $2200^\circ$  C for 30 min, and  $(c)$  as  $(b)$  but with an additional annealing at  $1800^{\circ}$  C for 10 h. X-ray spectra were taken at several points on one grain boundary (and other grain boundaries for some samples) and in the bulk, and some variation of the A1/Si count ratio, within 20%, was observed.

## **4. Discussion**

# 4.1. Heat of segregation

## *4. 1.1. Equilibrium segregation theory*

Applying the method of statistical thermodynamics to the problem of grain boundary segregation, McLean [10] derived an expression:

$$
\frac{X_{\text{gb}}}{1 - X_{\text{gb}}} = \frac{X_1}{1 - X} \exp\left(\frac{E_s}{RT}\right),\tag{1}
$$

where  $X_{\rm gb}$  is the solute molar fraction at the grain boundary,  $X_1$  is the solute molar fraction in the bulk,  $E_s$  is the free energy of segregation at the grain boundary, which is the *difference* in energy



*Figure 4* (a) STEM micrographs (annular dark-field image) and (b) X-ray spectrum taken at the second phase by UTW detector in hot-pressed SiC.



*Figure 5* (a) and (b) STEM micrographs (bright-field images) of hot-pressed SiC.

between an atom in the bulk and an atom on the grain boundary,  $R$  is the gas constant and  $T$  is the absolute temperature. When the vibrational entropy is taken into account, Equation 1 becomes

$$
\frac{X_{\text{gb}}}{1 - X_{\text{gb}}} = \frac{AX_1}{1 - X_1} \exp\left(\frac{E_s}{RT}\right),\tag{2}
$$

where  $A = \exp(-S/R)$  and S is the difference in vibrational entropy between a solute atom on the grain boundary and a solute atom in the bulk. For the segregation of a dilute solute, Equation 2 may be approximated as

$$
\frac{X_{\text{gb}}}{X_1} \equiv \beta_{\text{gb}} = A \exp\left(\frac{E_s}{RT}\right),\tag{3}
$$

where  $\beta_{sh}$  is the grain-boundary enrichment ratio.

## *4. 1.2. STEM data analysis*

Quantitative analysis of the X-ray information from the STEM can be accomplished in a straightforward manner if the specimen is thin enough to ignore absorption and fluorescence corrections. The most widely accepted technique is the Cliff-Lorimer approach [11], which uses the following expression:

$$
\frac{I_{\mathbf{A}}}{I_{\mathbf{B}}} = (k_{\mathbf{AB}})^{-1} \frac{X_{\mathbf{A}}}{X_{\mathbf{B}}},
$$
(4)

where  $I_A$  and  $I_B$  are the measured characteristic X-ray intensities and  $X_A$  and  $X_B$  are the weight fractions of two elements A and B in the thin film and the constant,  $k_{AB}$ , varies with operating voltage but is independent of sample thickness and composition if the two intensities are measured



*Figure 6* Results of X-ray microanalysis across the grain boundary in hot-pressed SiC.

simultaneously and if the thin-film criterion (no absorption or fluorescence) is satisfied.

In some systems, for example, NiO-doped MgO [12], significant absorption of X-ray occurs even in the thin film, so that an absorption correction must be applied to Equation 4, such that [13]

$$
\frac{X_{\mathbf{A}}}{X_{\mathbf{B}}} = k_{\mathbf{A}\mathbf{B}} \frac{I_{\mathbf{A}}}{I_{\mathbf{B}}} \exp\left[-\frac{\rho t}{2} (\chi_{\mathbf{B}} - \chi_{\mathbf{A}})\right], \quad (5)
$$

where  $\rho$  is the specimen density, t is the specimen thickness, and  $X$  for element  $i$  is given by

$$
X_i = \frac{\mu}{\rho} \bigg|_{\text{spec}}^i \csc \alpha, \tag{6}
$$

where  $\mu/\rho$ ]<sub>spec</sub> is the mass absorption coefficient for the characteristic X-ray of element  $i$  in the specimen, and  $\alpha$  is the X-ray take-off angle. In the present study,  $\mu/\rho$ ]<sub>spec</sub> and  $\mu/\rho$ ]<sub>spec</sub> can be calculated by using mass absorption coefficients,  $C_i$ , reported by Heinrich [14] from the equations:

$$
\frac{\mu}{\rho}\bigg|_{\text{spec}}^{\text{Si}} = \frac{\mu}{\rho}\bigg|_{\text{Si}}^{\text{Si}}C_{\text{Si}} + \frac{\mu}{\rho}\bigg|_{\text{Al}}^{\text{Si}}C_{\text{Al}} + \frac{\mu}{\rho}\bigg|_{\text{C}}^{\text{Si}}C_{\text{C}} \qquad (7)
$$

and

$$
\frac{\mu}{\rho}\bigg|_{\text{spec}}^{\text{Al}} = \frac{\mu}{\rho}\bigg|_{\text{Si}}^{\text{Al}}C_{\text{Si}} + \frac{\mu}{\rho}\bigg|_{\text{Al}}^{\text{Al}}C_{\text{Al}} + \frac{\mu}{\rho}\bigg|_{\text{C}}^{\text{Al}}C_{\text{C}}.\tag{8}
$$

Using  $C_{\text{Al}} = 0.01$  and  $\alpha = 33^{\circ}$ ,  $X_{\text{Al}}$  and  $X_{\text{Si}}$  were calculated to be 525 and 373 cm<sup>2</sup> g<sup>-1</sup>. The exponential term in Equation 5 is therefore very close to unity, 1.004 at  $t = 100$  nm and 1.02 at  $t =$ 500 nm, and it can therefore be neglected in the present study.

Combining Equations 3 and 4, the grain boundary enrichment ratio,  $\beta_{\rm gb}$ , of A1 in SiC is expressed as

$$
\beta_{\rm gb} = \frac{(I_{\rm Al}/I_{\rm Si})_{\rm gb}}{(I_{\rm Al}/I_{\rm Si})_1} \frac{(X_{\rm Si})_{\rm gb}}{(X_{\rm Si})_1},\tag{9}
$$



where  $(I_{A1}/I_{Si})_{gb}$  and  $(I_{A1}/I_{Si})_{1}$  are the X-ray intensity ratios at the grain boundary and in the bulk and  $(X_{\text{Si}})_{\text{gh}}$  and  $(X_{\text{Si}})_{\text{l}}$  are the values of  $X_{\text{Si}}$  at the grain boundary and in the bulk. In the actual STEM analysis,  $(I_{A1}/I_{Si})_{gb}$  cannot be measured directly since the analysed volume may contain both the grain boundary and bulk regions and, hence, the measured ratios may be smaller than the true ratios. Let us define the measured grainboundary enrichment ratio, *3'gb,* as

$$
\beta'_{\rm gb} = \frac{(I_{\rm Al}/I_{\rm Si})_{\rm br}}{(I_{\rm Al}/I_{\rm Si})_{\rm l}},\tag{10}
$$

where  $(I_{A1}/I_{Si})_{br}$  is the measured X-ray intensity ratio at the boundary region. The results are summarized in Table I. The heat of segregation was estimated for two limiting cases: for  $(I_{A1}/I_{Si})_{\text{br}} \sim$  $(I_{\text{Al}}/I_{\text{Si}})_{\text{gb}}$  and for  $(I_{\text{Al}}/I_{\text{Si}})_{\text{br}} \leq (I_{\text{Al}}/I_{\text{Si}})_{\text{gb}}$ .

For the first case, since the values of  $\beta'_{\rm gb}$  are not large ( $\sim$  6 at 1800°C),  $(X_{\text{Si}})_{\text{gb}}/(X_{\text{Si}})_{\text{l}}$  may be assumed to be unity. Thus, from Equations 3, 9, and 10,

$$
E_{\rm s} = \frac{\partial \ln \beta_{\rm gb}'}{\partial (I/T)} R. \tag{11}
$$

Fig. 7 shows a plot of  $\ln \beta'$  against  $T^{-1}$  and, from a slope of the least-squares fitted line, a value of  $E_s = 116 \text{ kJ} \text{ mol}^{-1}$  is obtained.

For the second limiting case, considering the approximate geometry of the analysed volume shown in Fig. 8, the X-ray intensity of species  $i$  at the boundary region,  $(I_i)_{\text{br}}$ , may be expressed as

$$
(I_i)_{\text{br}} = (I_i)_{\text{gb}} \frac{V_{\text{gb}}}{V_1} + (I_i)_{\text{l}} \left(1 - \frac{V_{\text{gb}}}{V_1}\right), \quad (12)
$$

where  $V_{\rm gb}$  is the volume of the grain boundary and  $V_1$  is the total analysed volume. From Fig. 8 it can be seen that

$$
V_{\rm gb} = dwt \tag{13}
$$

and





*Figure* 7 ln  $\beta_{\text{gh}}'$  plotted against  $T^{-1}$ . The slope of the curve gives the lower limit of  $E_s$ .

$$
V_1 = \frac{\pi}{4}d^2t,\tag{14}
$$

where  $d$  is the diameter of the area analysed,  $w$  is the width of the grain boundary and  $t$  is the depth analysed. Therefore

$$
\frac{V_{\rm gb}}{V_1} = \frac{4w}{\pi d}.
$$
 (15)

Combining Equations 3, 9, 10 and 12 gives

$$
\beta_{\text{gb}} = \frac{\pi d}{4w} \left[ \beta_{\text{gb}}' \frac{(I_{\text{S}})_{\text{br}}}{(I_{\text{S}})_{1}} - 1 \right] + 1. \tag{16}
$$

Assuming that  $(I_{\text{Si}})_{\text{br}}/(I_{\text{Si}})_{\text{l}}$  is unity and that  $\pi d/4w \geq 1$ , Equation 16 is approximated to

$$
\beta_{\text{gb}} \sim \frac{\pi d}{4w} (\beta_{\text{gb}}' - 1). \tag{17}
$$

The heat of segregation may be estimated from Equations 3 and 17, assuming that  $\pi d/4w$  is constant

$$
E_{\rm s} \sim \frac{\beta \ln \left(\beta_{\rm gb}' - 1\right)}{\partial T^{-1}} R. \tag{18}
$$

This relation was tested using the data shown in Table I and the relation is plotted in Fig. 9. A least-squares fit method yields a value for the heat of segregation of  $174 \text{ kJ} \text{ mol}^{-1}$ . There is some



*Figure 8* Schematic drawing of the approximate geometry for X-ray microanalysis.

uncertainty associated, with the proceding data analysis since several assumptions and approximations were made. For example, the quantity *rrd/4w* was assumed to be constant, but it may change for each analysis.

The results obtained indicate that equilibrium segregation of Al takes place in the Al-SiC system with the estimated heat of segregation between 116 and  $174 \text{ kJ} \text{ mol}^{-1}$ .

## 4.2. Driving force for the segregation

One of the driving forces for the segregation is the strain energy due to a solute that fits poorly in the lattice. McLean [10] derived from the elasticity theory the distortion energy around each solute atom, W, such that

$$
W = \frac{24\pi K G r^3 \epsilon^2}{3K + 4G}, \qquad (19)
$$

where  $K$  is the bulk modulus of the solute,  $G$  is the shear modulus of the solvent,  $r$  is the radius of the solute atom *in situ* on the site, and e is the misfit, defined as

$$
\epsilon = (r_1 - r_0)/r_1, \qquad (20)
$$

where  $r_1$  is the radius of the isolated solute atom and  $r_0$  is the radius of the occupied site in the lattice. The strain energy contribution to the segregation may be estimated from the above equations knowing that A1 substitutes for Si [9]. Substitutions of  $K = 1.0 \times 10^5$  MPa,  $G = 1.9 \times 10^5$  MPa,  $r =$  $r_1 = 0.126$  nm and  $r_0 = 0.117$  nm into Equations 19 and 20 yield a value for W of about 3 kJ mol<sup> $-1$ </sup> which is between forty and sixty times smaller



*Figure 9* ln ( $\beta_{\text{gb}}' - 1$ ) plotted against  $T^{-1}$ . The slope of the curve gives the upper limit of  $E_s$ .

than the observed heat of segregation. Although this is a crude estimate, and is probably associated with a large error, the difference in the energies is so large that the strain energy seems to be a negligible factor. Johnson [15] observed a heat of adsorption of  $116 \text{ kJ}$  mol<sup>-1</sup> for Ca segregation in  $Al_2O_3$ . Since the difference in sizes of  $Ca^{2+}$  and  $Al^{3+}$  ions is quite large,  $\epsilon = 0.98$ , he rationalized the results using Equations 16 and 17. In the present case,  $\epsilon$  is estimated to be about 0.08 and, since W is proportional to the square of  $\epsilon$ , it is concluded that the strain energy as a driving force is negligible.

Electrostatic potential at the grain boundary becomes the major driving force for segregation in some ionic materials. In the present case, however, there are a number of electronic carriers at high temperatures which could more easily form space charge layers so that dopant space charge segregation seems unlikely.

The probable explanation for the experimentally observed heat of adsorption lies in the covalent bonding characteristics. Bonding in SiC is characterized by the tetrahedral hydridized orbital  $sp^3$ , whereas A1, having one 3p-electron, is less capable of forming or approaching the formation of such a configuration [16]. Thus, A1 may be more easily fitted into distorted sites, e.g., the grain boundary,

where dangling bonds would have higher energy without the solute segregation.

## **4.3. Grain-boundary diffusion of AI**

A loss of Al during heat treatment at  $2100^{\circ}$  C for 3 h was observed in the sintered sample, as stated in Section 3.2. A diffusion length calculated from the bulk diffusion constant,  $D_1$ , of Al at that temperature, however, is too small to explain the result.  $D_1$  at 2100°C is estimated to be approximately  $10^{-13}$  cm<sup>2</sup> sec<sup>-1</sup> [17].  $(D_1t)^{1/2}$  is then calculated to be approximately  $0.3~\mu$ m, which is about 500 times smaller than the sample thickness during the heat treatment. Therefore, it is likely that the grain-boundary diffusion is much faster and that it led to the loss of A1.

An indication of the fast grain-boundary diffusion of A1 was also observed for the hotpressed material. The STEM specimen, which was annealed, thinned and observed by STEM (Sample 3 in Table I), was further annealed at  $1350^{\circ}$  C for 15 min. The same specimen was then observed by STEM and no enhancement of the A1 concentration at the grain boundary was observed.

From these results, the lower limit of the grain-boundary diffusion coefficient,  $D_{\rm gh}$ , may be estimated from the condition

$$
(D_{\rm gb}t)^{1/2} > \frac{h}{2},\tag{21}
$$

where  $h$  is the specimen thickness during annealing. Substitutions of  $h = 150~\mu m$  and  $h = 200.0~\mu m$ yield  $D_{\rm gb} > 5 \times 10^{-9}$  cm<sup>2</sup> sec<sup>-1</sup> at 2100°C and  $D_{\rm gh} > 10^{-13}$  cm<sup>2</sup> sec<sup>-1</sup> at 1350°C, respectively. The latter value is in accord with the estimated pipe diffusion constant at the same temperature  $\left(\sim 10^{-12} \text{ cm}^2 \text{ sec}^{-1}\right)$  reported by Tajima et al. [17].

#### **5. Conclusions**

(a) Grain-boundary segregation of A1 was observed in sintered and hot-pressed Al-doped SiC. The amount of segregation was enhanced by lower temperature heat treatments consistent with the equilibrium segregation theory. An estimated heat of segregation of between 116 and  $174 \text{ kJ} \text{ mol}^{-1}$ was calculated for the Al-saturated hot-pressed material from the STEM data and using the model of McLean. Strain energy as a driving force was considered negligible. The difference in the nature of bonding between the solute and solvent atoms was concluded to be the major driving force for the segregation.

(b) A loss of A1 was observed when thin samples were heat-treated. Results are interpreted as indicating that grain boundaries are high diffusivity paths for A1.

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